

Notice of References Cited	Application/Control No. 10/639,929	Applicant(s)/Patent Under Re xamination OYEVAAR ET AL.	
	Examiner MICHAEL L. SHIPPEN	Art Unit 1621	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,635,788 B1	10-2003	Oyevaar et al.	568/728
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Kirk-Othmer Encyclopedia of Chemical Technology," 4 th Ed., Vol. 19, pp. 584-599 (1996)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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